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Date: Nov. 3, 2004

TO: Examiner Markoff, Alexander (703) 872-9311
Art Unit: 1746

FAX Operator: Kathy Dixon

FAX Number: (248) 540-4035

Telephone Number: (248) 540-4040

Subject Matter: 10/ 082,009 Attorney Doc: 67,200-646

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U.S.S.N. 10/082,009

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Shih et al.

Group Art Unit: 1746

Serial No.: 10/082,009

Examiner: Alexander Markoff

Filed: 02/20/2002

In Response to Office Action
Dated: 09/17/2004

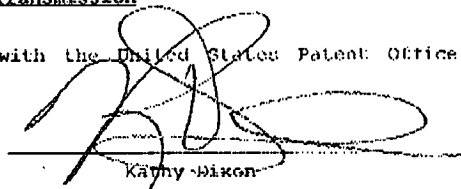
For: METHOD FOR PREVENTING CHEMICAL ATTACK ON A
COPPER CONTAINING SEMICONDUCTOR WAFER

Attorney Docket No.: 67,200-646

Certificate of Facsimile Transmission

I hereby certify that this paper is being deposited with the United States Patent Office via
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Date: Nov. 3, 2004



Kathy Nixon

REQUEST FOR RECONSIDERATION

Commissioner for Patents
P.O. Box 1450
Alexandria, Va 22313-1450

Dear Sir:

In response to an Office Action mailed 09/17/2004
please consider the following remarks.